## Notice of References Cited Application/Control No. 10/525,600 Applicant(s)/Patent Under Reexamination STASTNY ET AL. Examiner Len Tran Art Unit Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,904,893	05-1999	Stein, Ulrich	266/46
*	В	US-6,843,958	01-2005	Korbik et al.	266/194
*	С	US-2005/0218569	10-2005	Stastny et al.	266/193
*	D	US-5,676,908	10-1997	Kubbutat et al.	266/193
*	Е	US-2004/0129187	07-2004	Korbik et al.	110/180
*	F	US-2004/0046292	03-2004	Heinrich, Peter	266/194
*	G	US-6,660,222	12-2003	Heinrich et al.	266/193
*	Н	US-6,470,958	10-2002	Solvi et al.	164/465
*	I	US-6,132,673	10-2000	Hille et al.	266/193
*	J	US-6,126,893	10-2000	Otsuka et al.	266/193
*	κ.	US-4,397,450	08-1983	Kammerling et al.	266/193
in Ti	L	US-			7, 1
	М	US-			

## **FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	·				
	0					
	Р					
	Q					
	R					
	s					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	·
	v	
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	x	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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